

*“Mechanical behavior of ultrathin sputter deposited porous amorphous Al<sub>2</sub>O<sub>3</sub> films”.* van der Rest A, Idrissi H, Henry F, Favache A, Schryvers D, Proost J, Raskin J-P, Van Overmeere Q, Padoen T, Acta materialia **125**, 27 (2017). <http://doi.org/10.1016/j.actamat.2016.11.037>